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PATENT
Attorney Docket No. 0553-0242.01

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:
Shunpei YAMAZAKI, et al.

Serial No.: 10/790,972

Filed: March 2, 2004

Examiner: Michael K. Luhrs

Art Unit: 2824

For: THIN FILM FORMING DEVICE, METHOD
OF FORMING A THIN FILM, AND SELF-
LIGHT-EMITTING DEVICE

I hereby certify that this correspondence is being
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Shannon Wallace

Name of applicant, assignee, or Registered Rep.

Shannon Wallace 9/28/05
Signature Date

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT C (AFTER FINAL)

Dear Sirs:

In response to the Final Rejection of June 28, 2005, please amend the above-identified
application as follows: